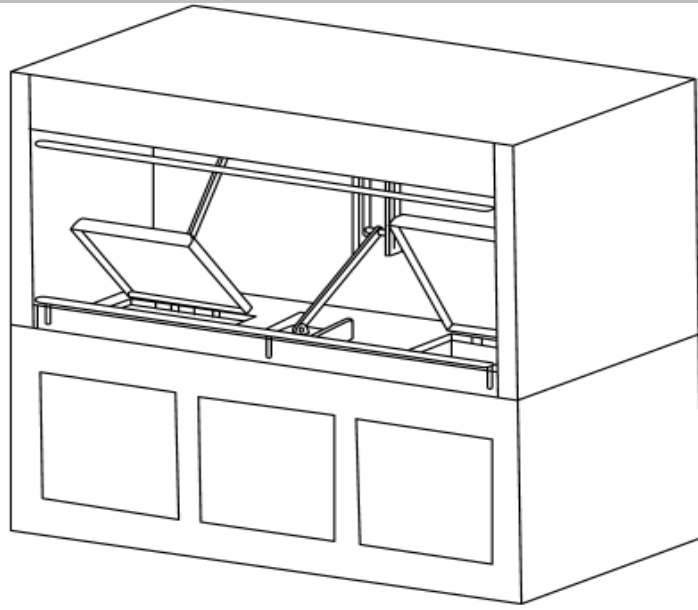




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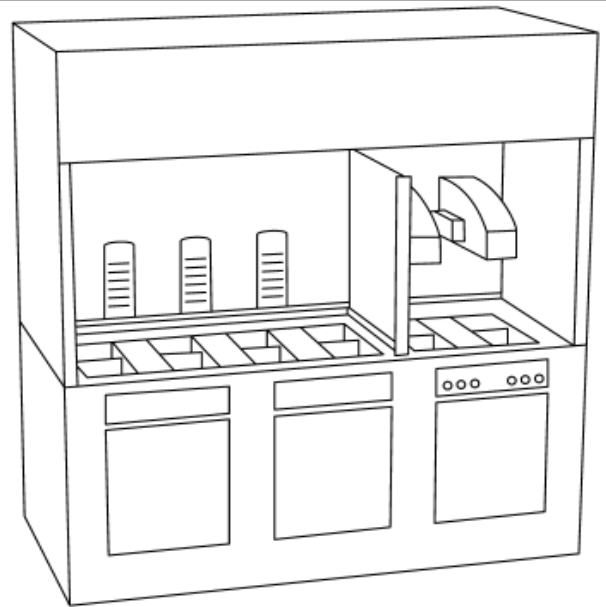


Manual wet bench

- for small output quantities
- for very long processing times
- for full flexibility
- For development wet benches

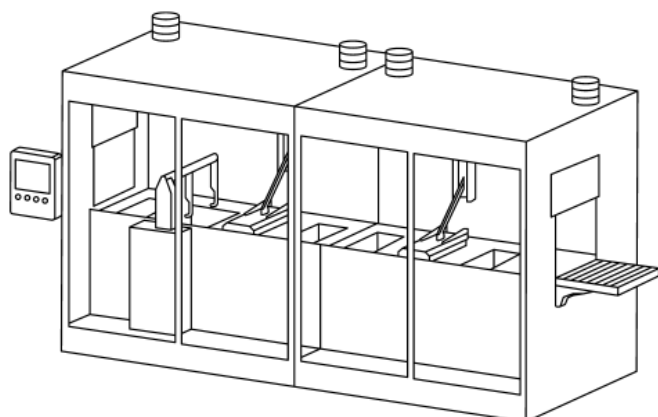
Semi- automatic wet bench

- for medium output quantities
- for hazardous chemicals
- With recurring movements in the pelvis



Fully automatic wet bench

- for large output requirements
- With short process times
- For hazardous chemicals
- Inclusive material/ workpiecefeeding



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possible applications

- surface cleaning
- etching
- developing
- stripping
- Lift- Off
- parts cleaning
- Drying with IPA/ hot air / HF- Ozone

Complete mapping of the common guidelines :

- SECS- Gem connection
- usage of FM910 compatible Material
- different wafer sizes/- thicknesses
- adaption to the existing certified process
- evaluation of new processes
- manufacturing in clean room environment with the individual requirements

Advantages for the industry:

- flexibility in relation to the different wafer sizes/ thicknesses
- no re-certification needed
- individual adaption to the existing manufacturing process



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